

Electronic Patent Application Fee Transmittal

Application Number:	10594252			
Filing Date:	26-Sep-2006			
Title of Invention:	Method and apparatus for forming oxynitride film and nitride film, oxynitride film, nitride film, and substrate			
First Named Inventor/Applicant Name:	Norifumi Fujimura			
Filer:	Abraham Jacob Rosner/Vanessa Ward			
Attorney Docket Number:	Q97348			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 3 months with \$0 paid	1253	1	1050	1050

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				1050